

Notice of References Cited	Application/Control No. 10/648,320		Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Vivian Chen		Art Unit 1773	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,652,979	11-2003	Takahashi et al.	428/458
	B	US-5,922,164	07-1999	Kimura et al.	156/308.2
	C	US-6,086,989	07-2000	Kubo et al.	428/335
	D	US-5,846,642	12-1998	Kimura et al.	428/323
	E	US-6,379,774	04-2002	Tojo et al.	428/141
	F	US-6,468,627	10-2002	Ono et al.	428/141
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.